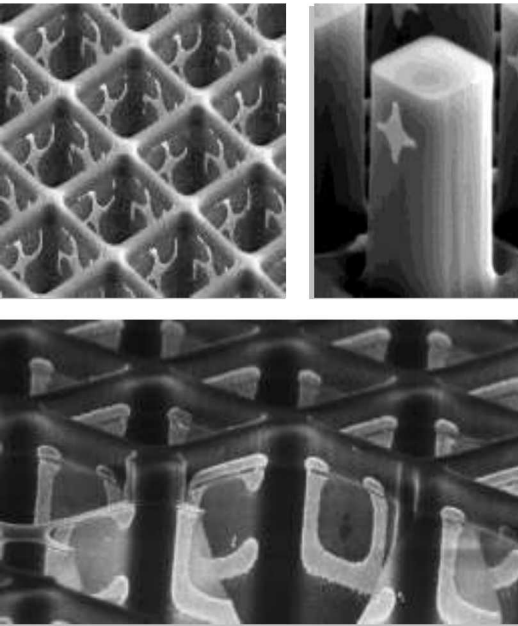




This paper describes objective technical results and analysis. Any subjective views or opinions that might be expressed in the paper do not necessarily represent the views of the U.S. Department of Energy or the United States Government.

SAND2020-2198C



# Unique Properties of 3D Infrared Metamaterials

**August 23, 2018**

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[dbburck@sandia.gov](mailto:dbburck@sandia.gov)



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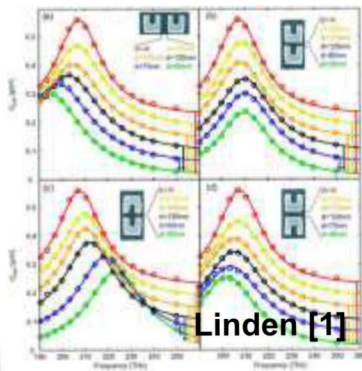
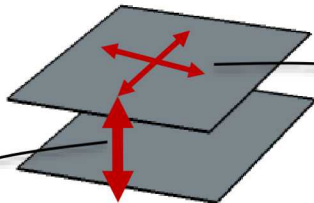
# Outline



1. 3D Metamaterial Atoms – unique coupling and scattering response
2. MPL Fabrication – 3D meta-films
3. Unique behaviors for 3D meta-atoms

# Comparing Coupling Mechanisms in Planar and Vertical Structures

**Stacked Planar Geometry**

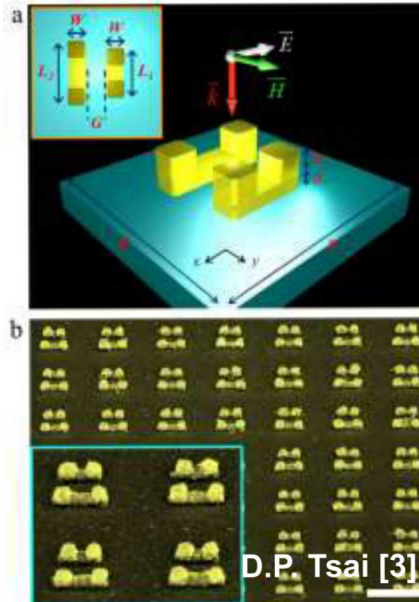
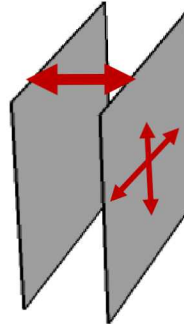


Linden [1]



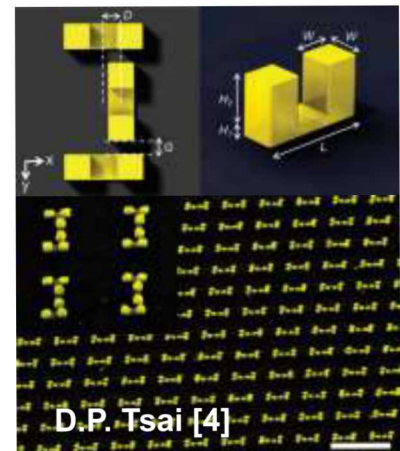
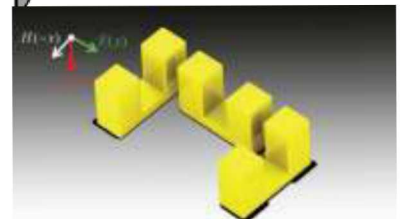
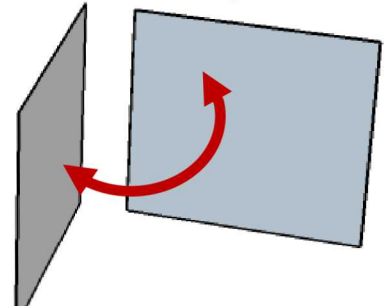
Giessen [2]

**Back-to-back Vertical Geometry**



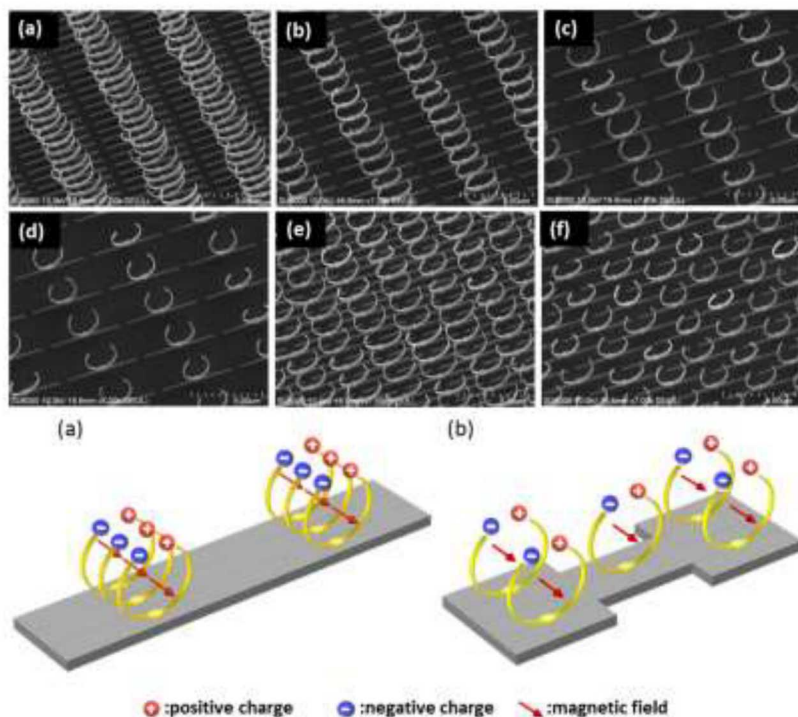
D.P. Tsai [3]

**Orthogonal Vertical Geometry**



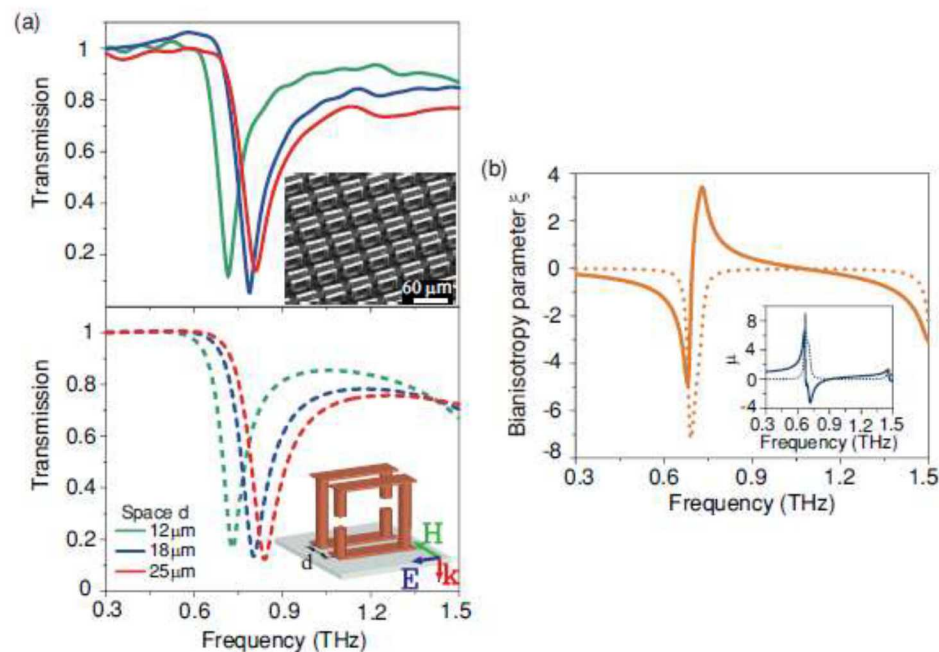
D.P. Tsai [4]

## Horizontally Oriented Magnetic Dipole



Tanaka and Chen [5]

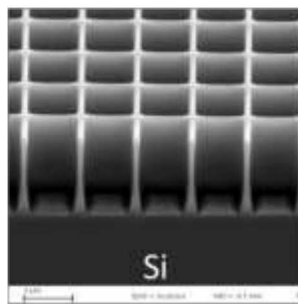
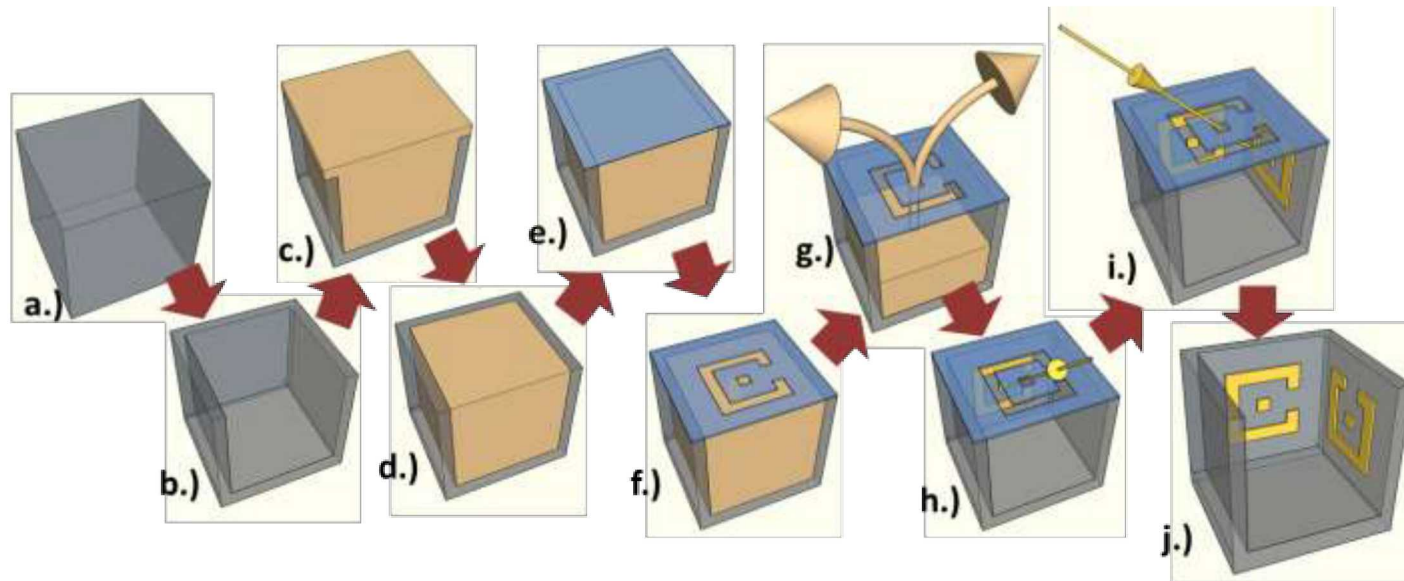
## Unambiguous Coupling to Normally Incident Magnetic Field



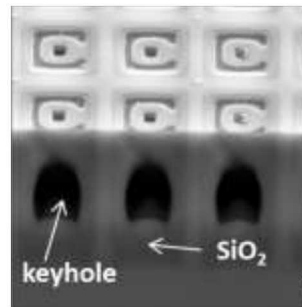
Averitt [6]

# Membrane Projection Lithography (MPL)

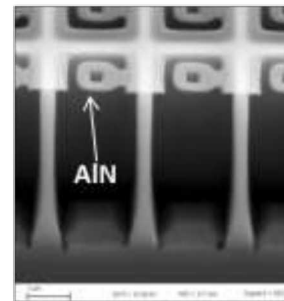
## 3D Micron-scale Fabrication Approach



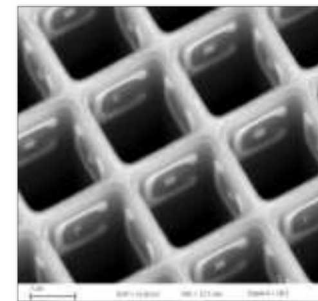
k.)



l.)



m.)

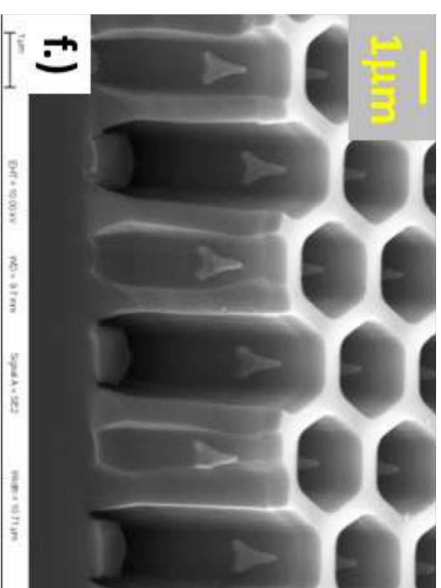
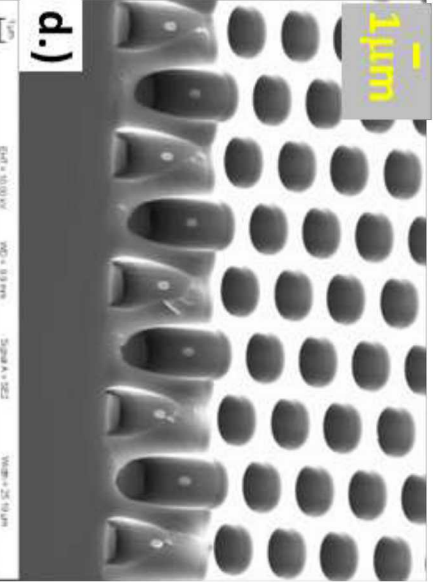
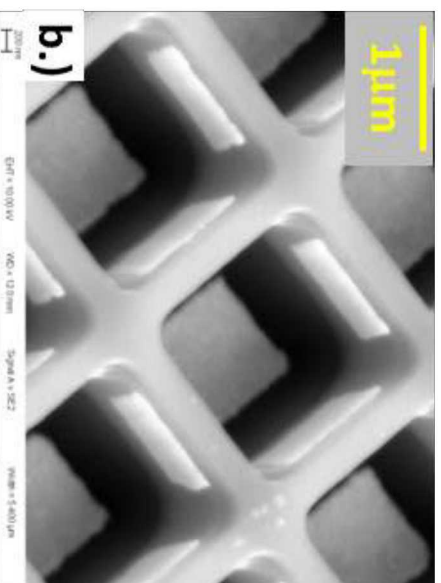
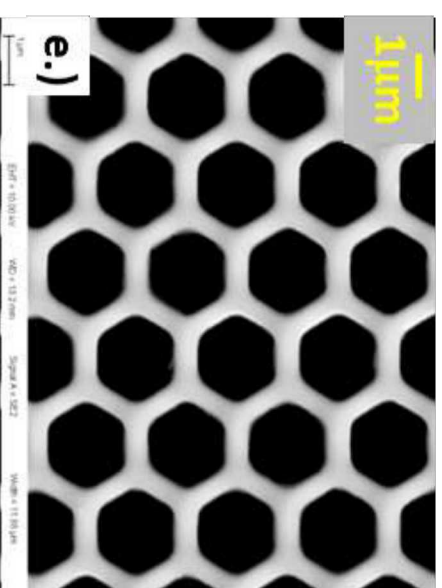
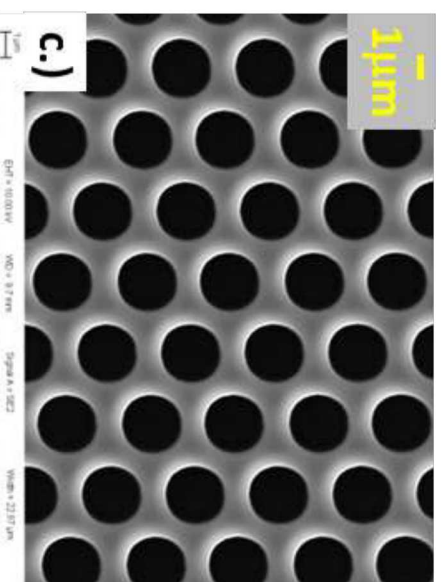
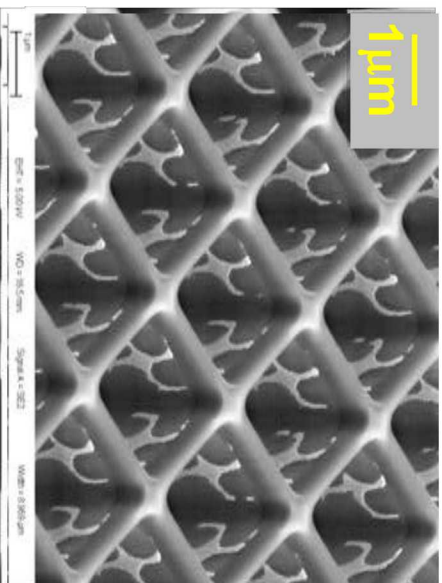


n.)

D. Bruce Burckel, Paul J. Resnick, Patrick S. Finnegan, , Michael B. Sinclair and Paul S. Davids “Micrometer-scale fabrication of complex three dimensional lattice+basis structures in silicon,” Optical Materials Express, , 5, 2231-2239, (2015).

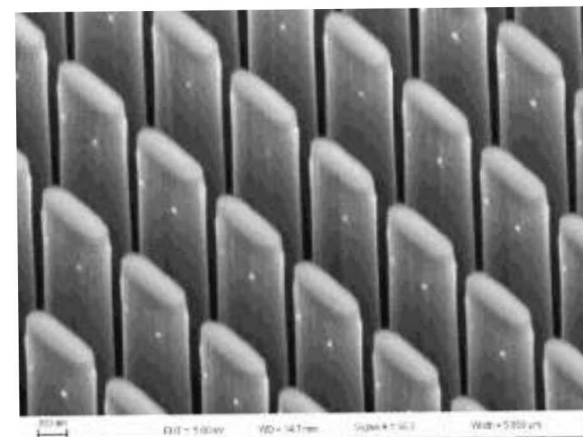
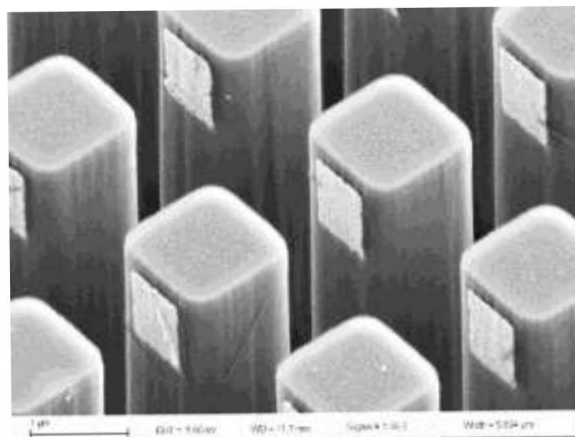
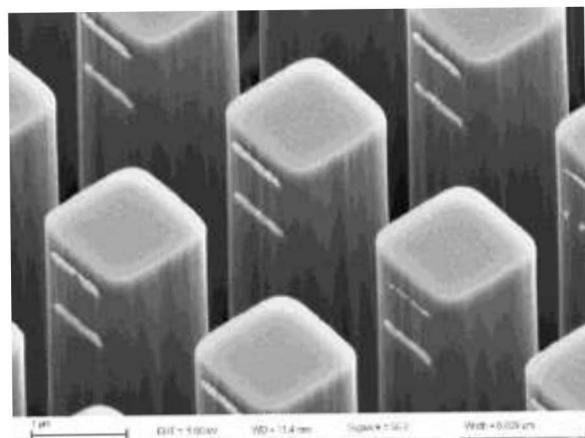
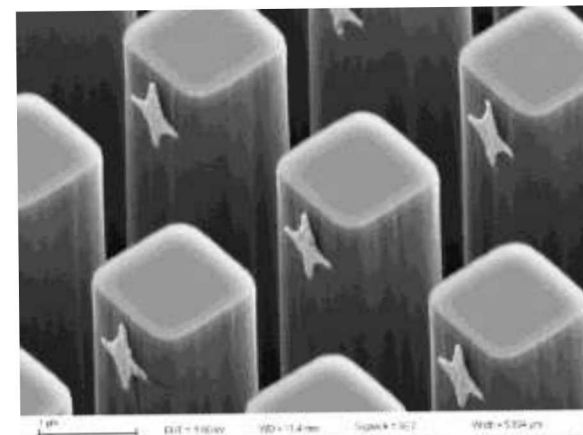
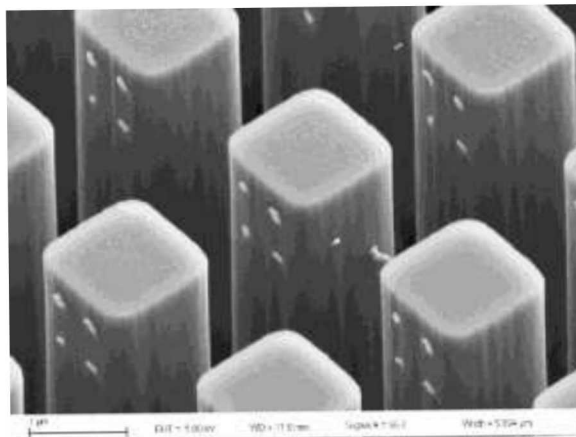
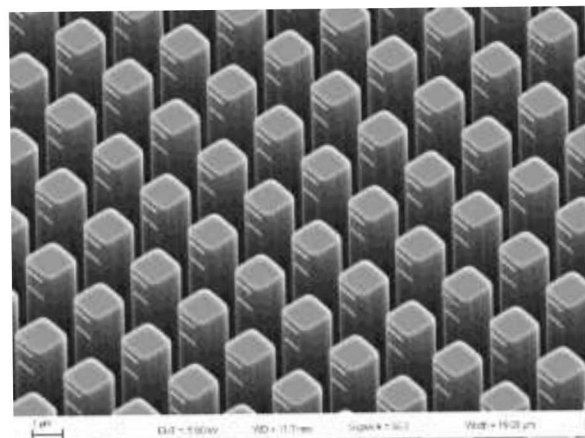


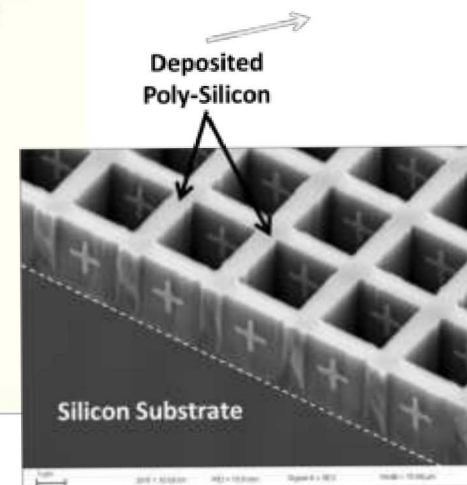
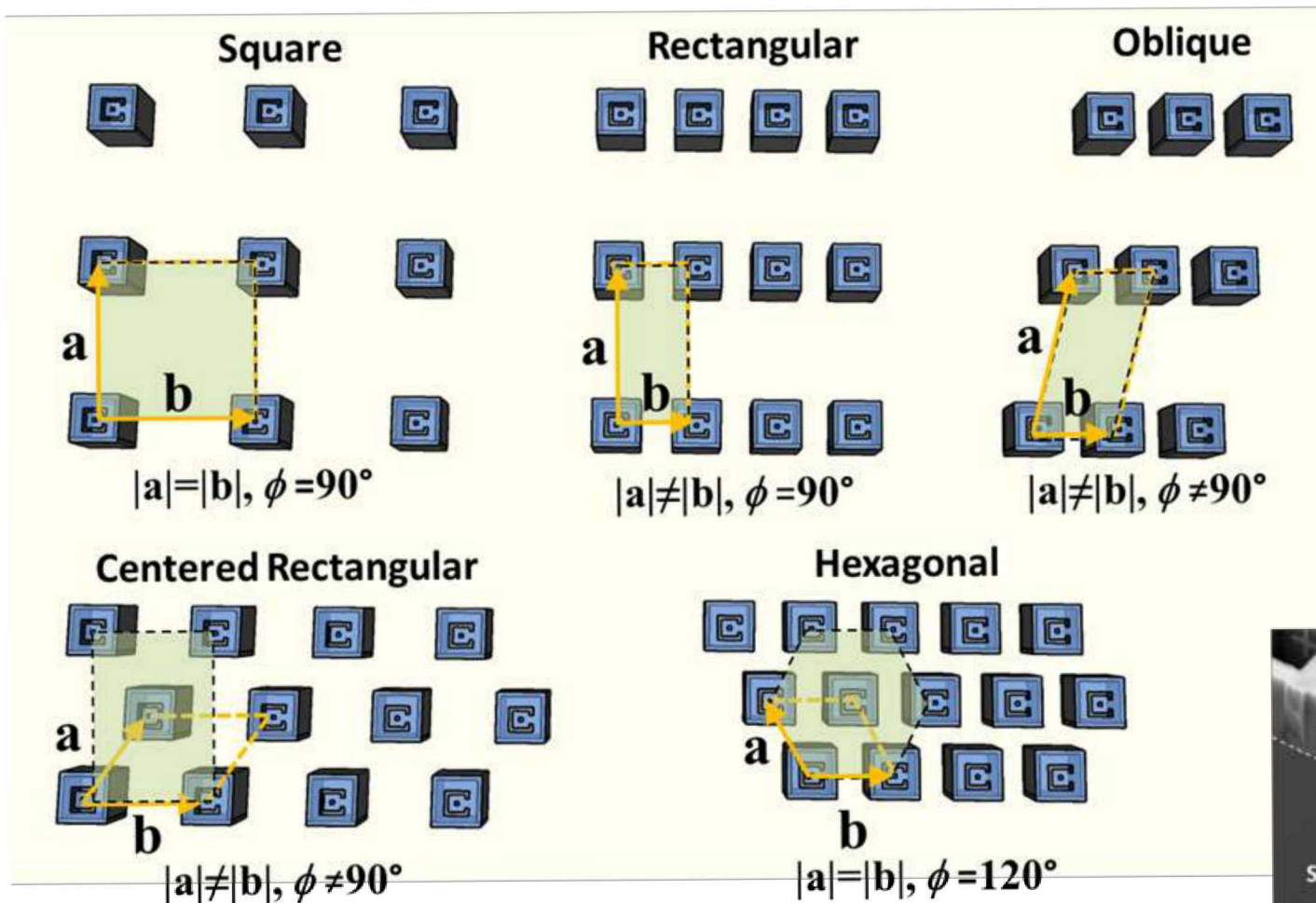
# 3D micron-scale Metamaterials





# 3D micron-scale Artificial Dielectrics



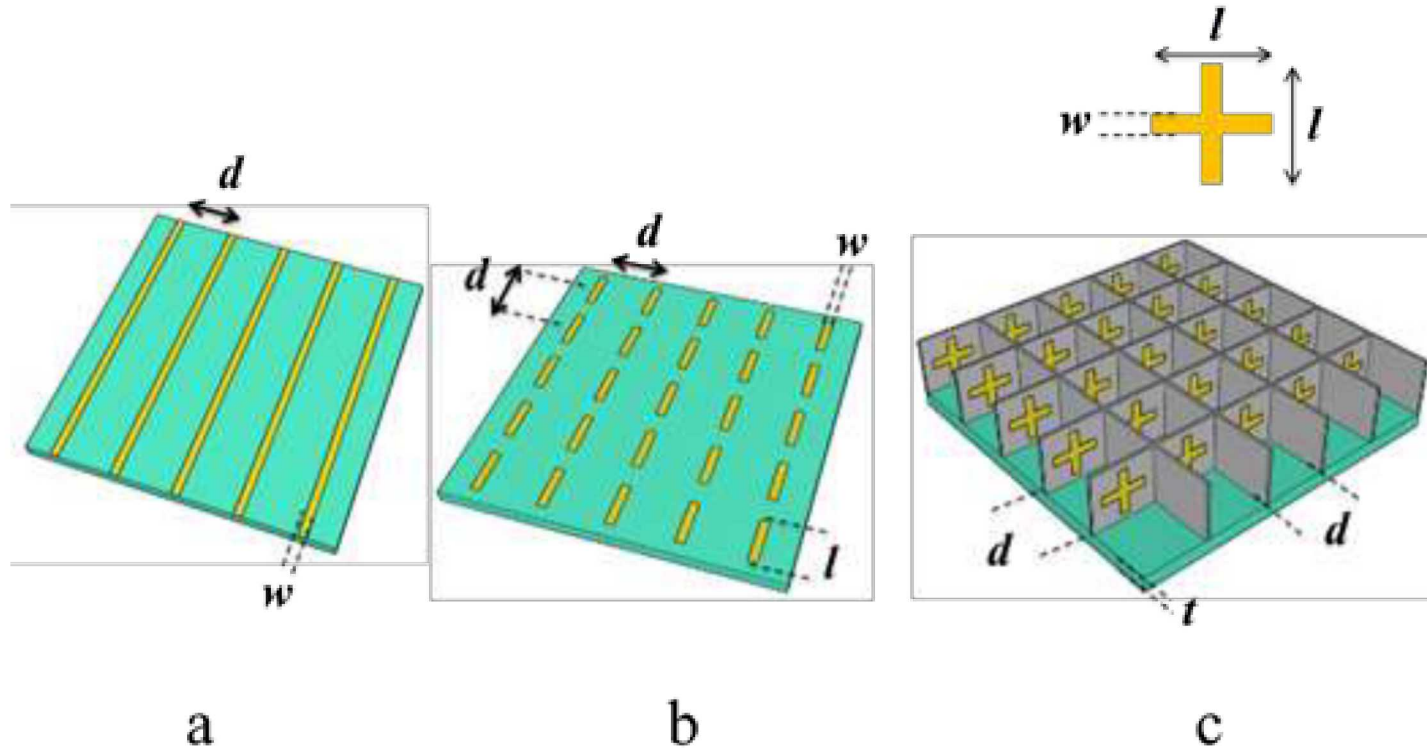


Path to all 14 3D Bravais Lattices?



# Vertical Back-To-Back Wire Grid Polarizers

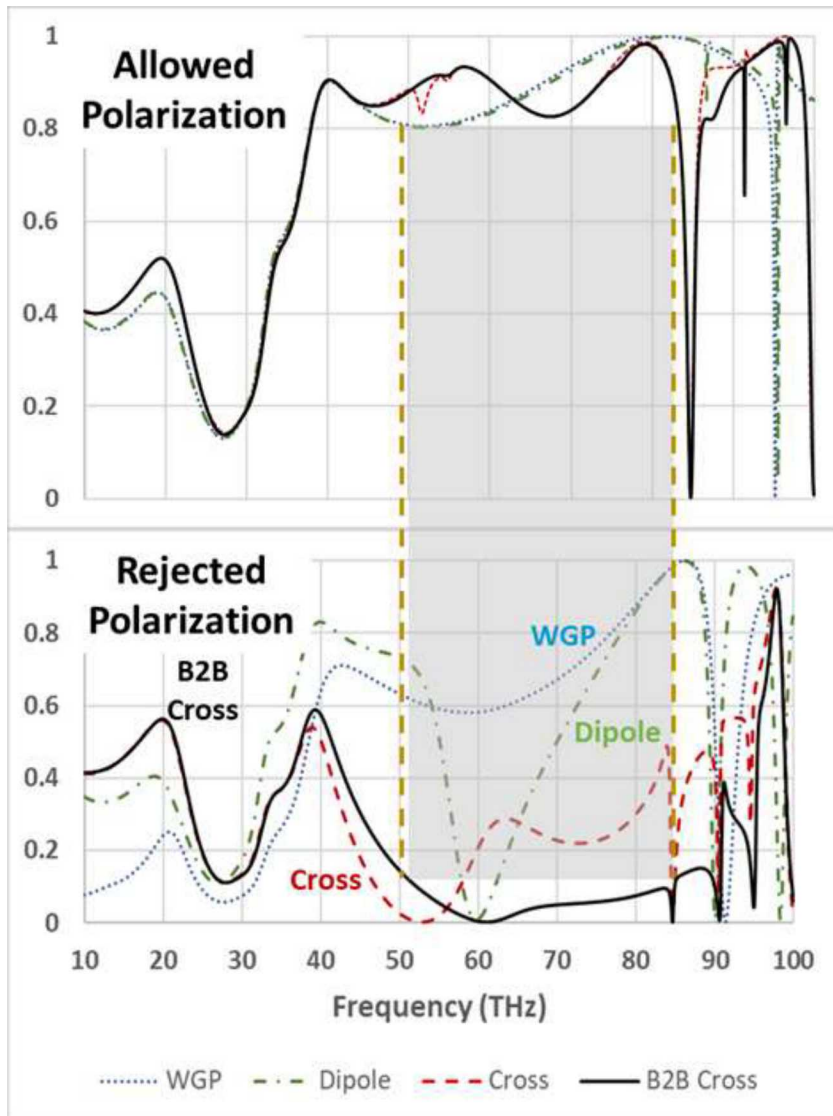
# Planar and Vertical Wire Grid Polarizer Geometries



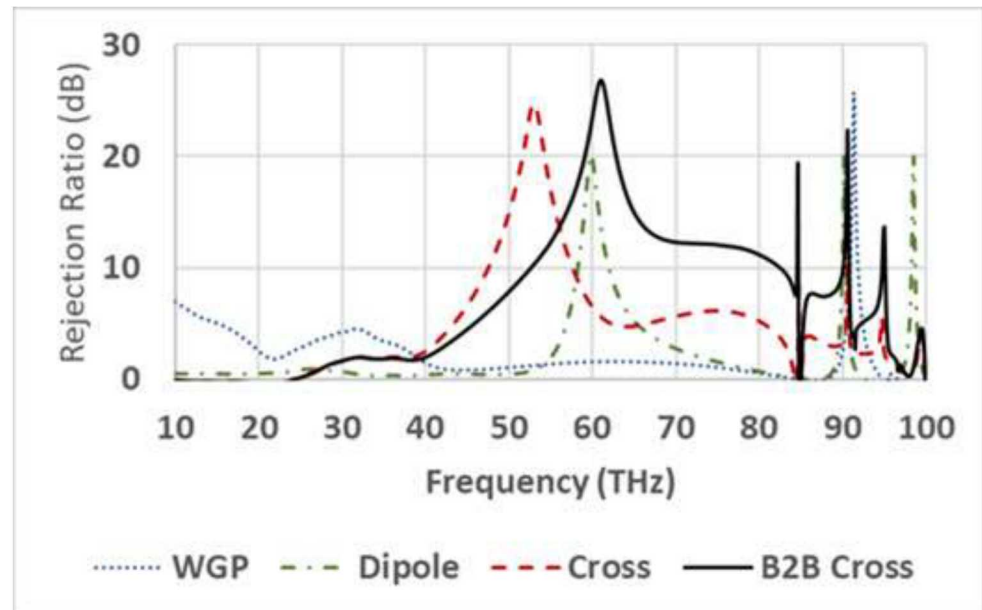
Submitted for publication



# Back-to-Back Vertical Cross WGP



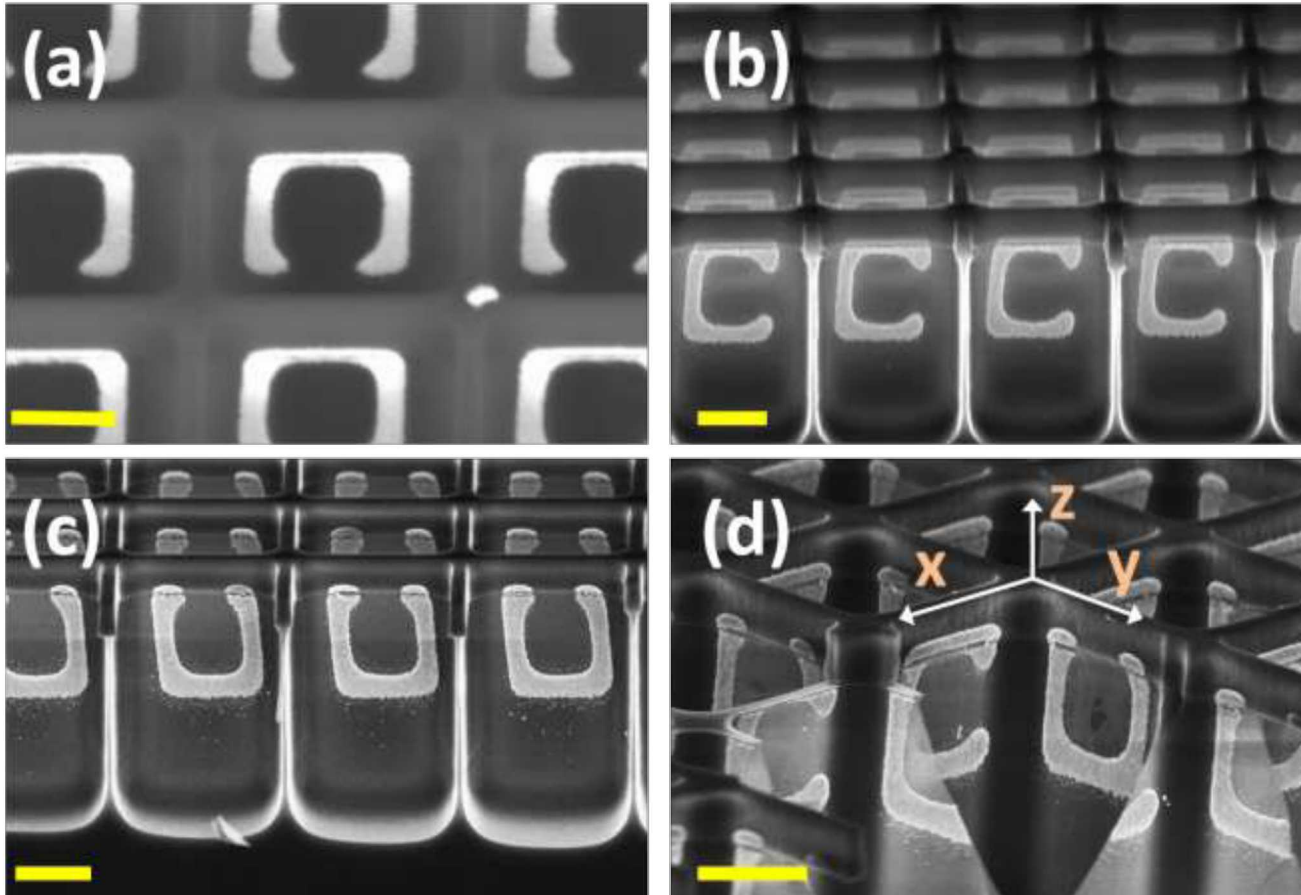
$$\text{Rejection Ratio} = 10 \cdot \log(T_{\text{passed}}/T_{\text{rejected}})$$





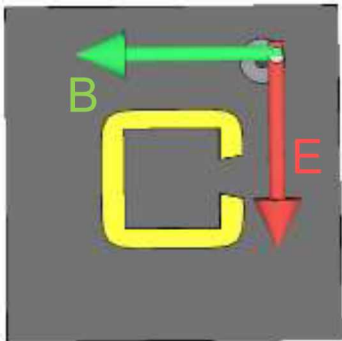
# Vertical Split Ring Resonators

# Cubic Unit Cells with 1-SRR and 2-SRR Bases

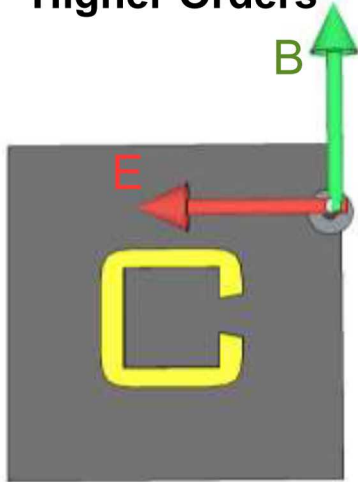


D. Bruce Burckel, Salvatore Campione, Paul S. Davids, and Michael B. Sinclair, "Three dimensional metafilms with dual channel unit cells," *Applied Physics Letters*, 110, 143107, (2017).

## Planar SRRs



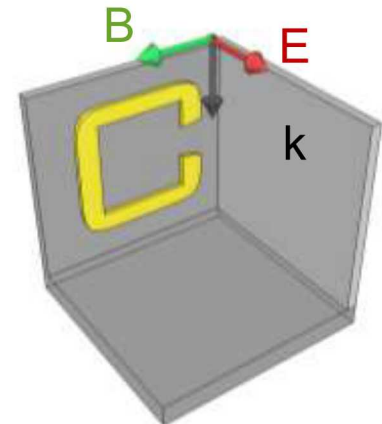
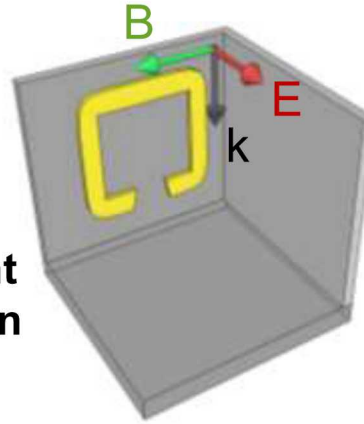
LC Resonance +  
Higher Orders



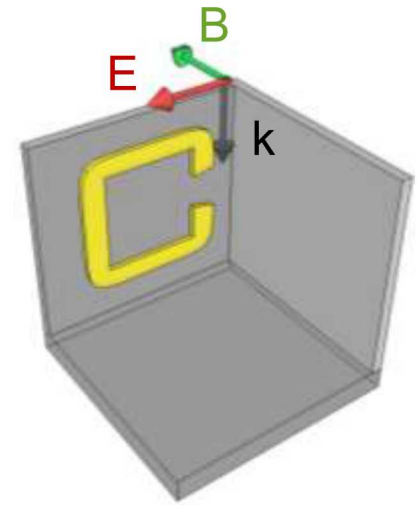
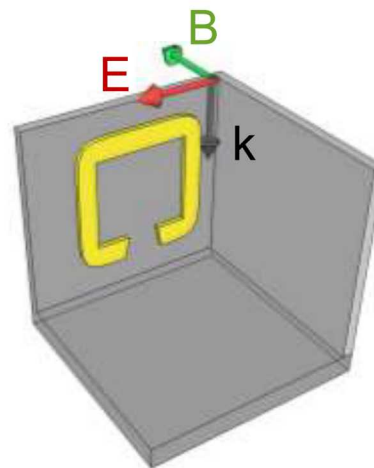
Higher Order  
Resonances

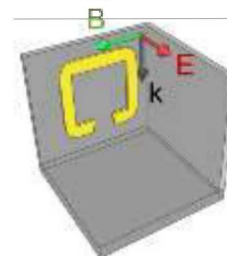
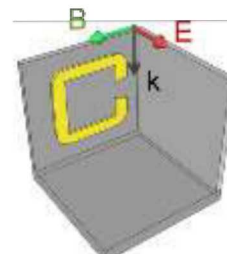
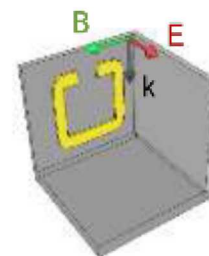
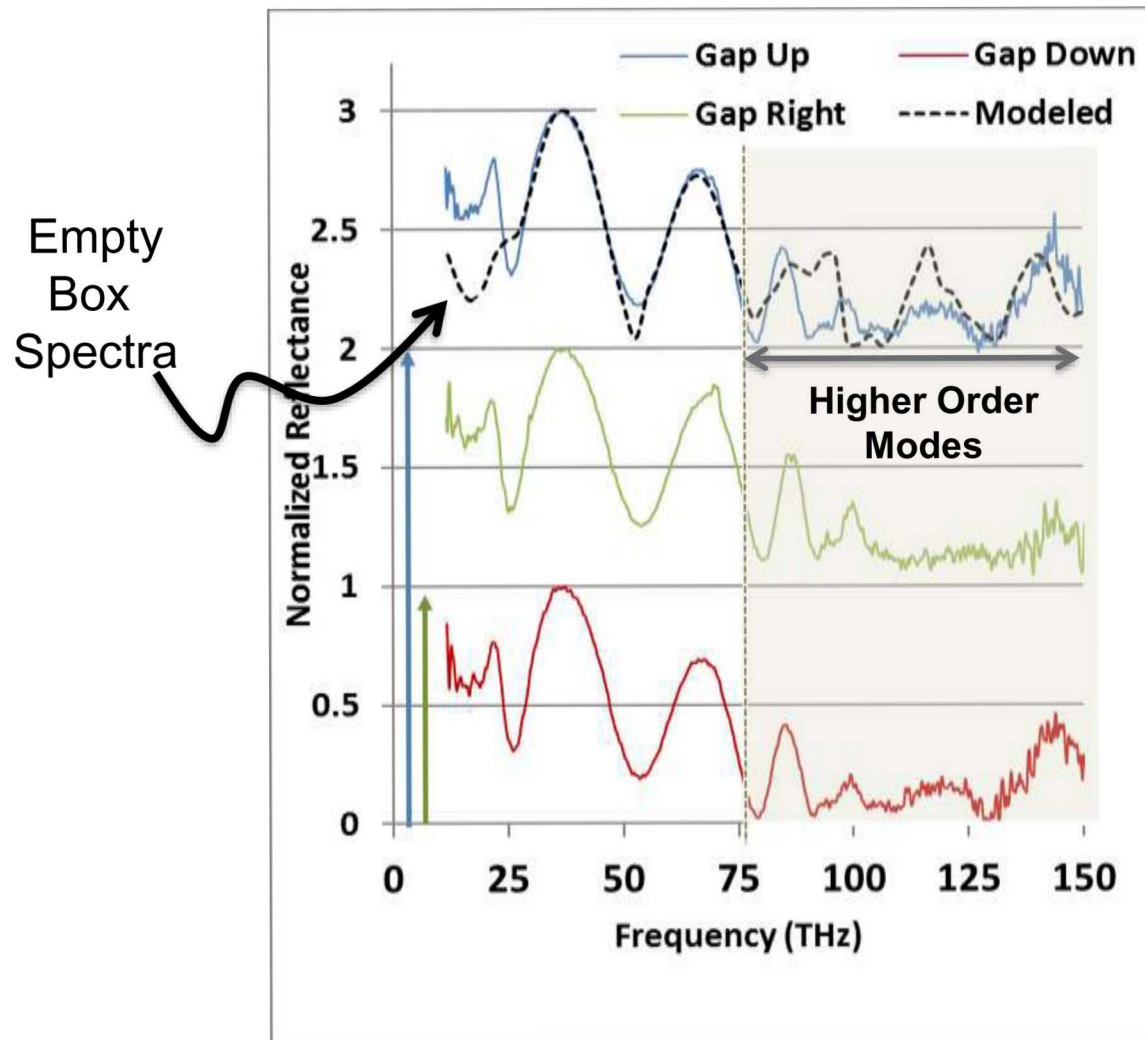
## Vertical SRRs

Transparent  
Polarization

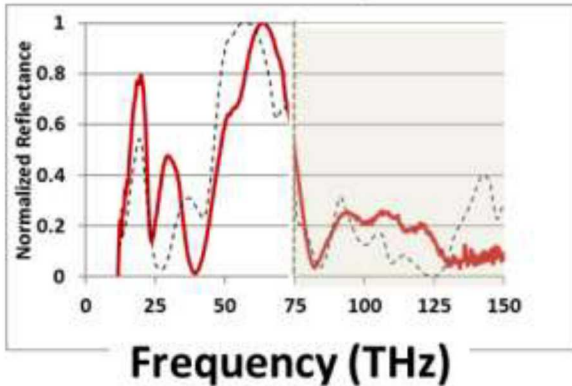
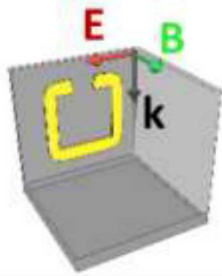


Resonant  
Polarization



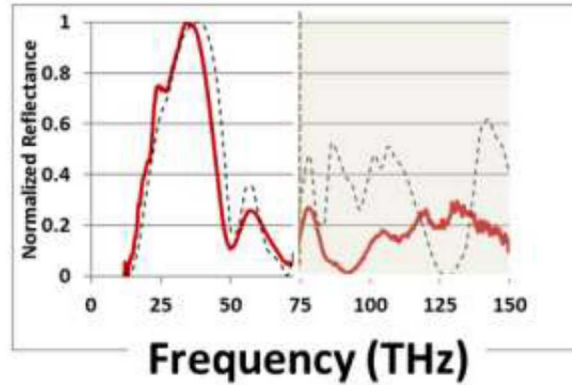
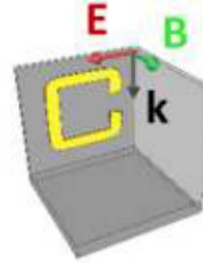


**Gap  
Up**



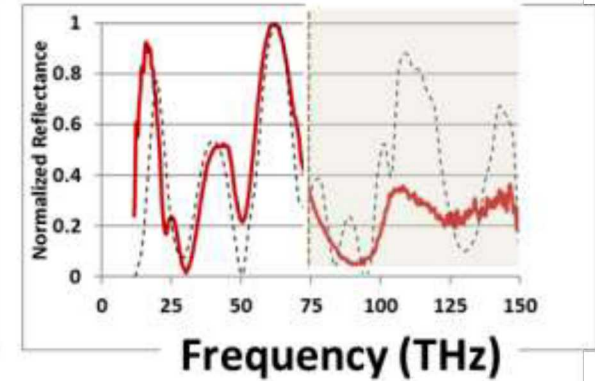
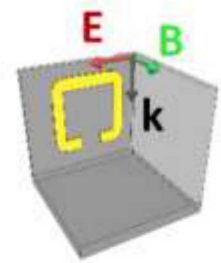
**(a)**

**Gap  
Right**



**(b)**

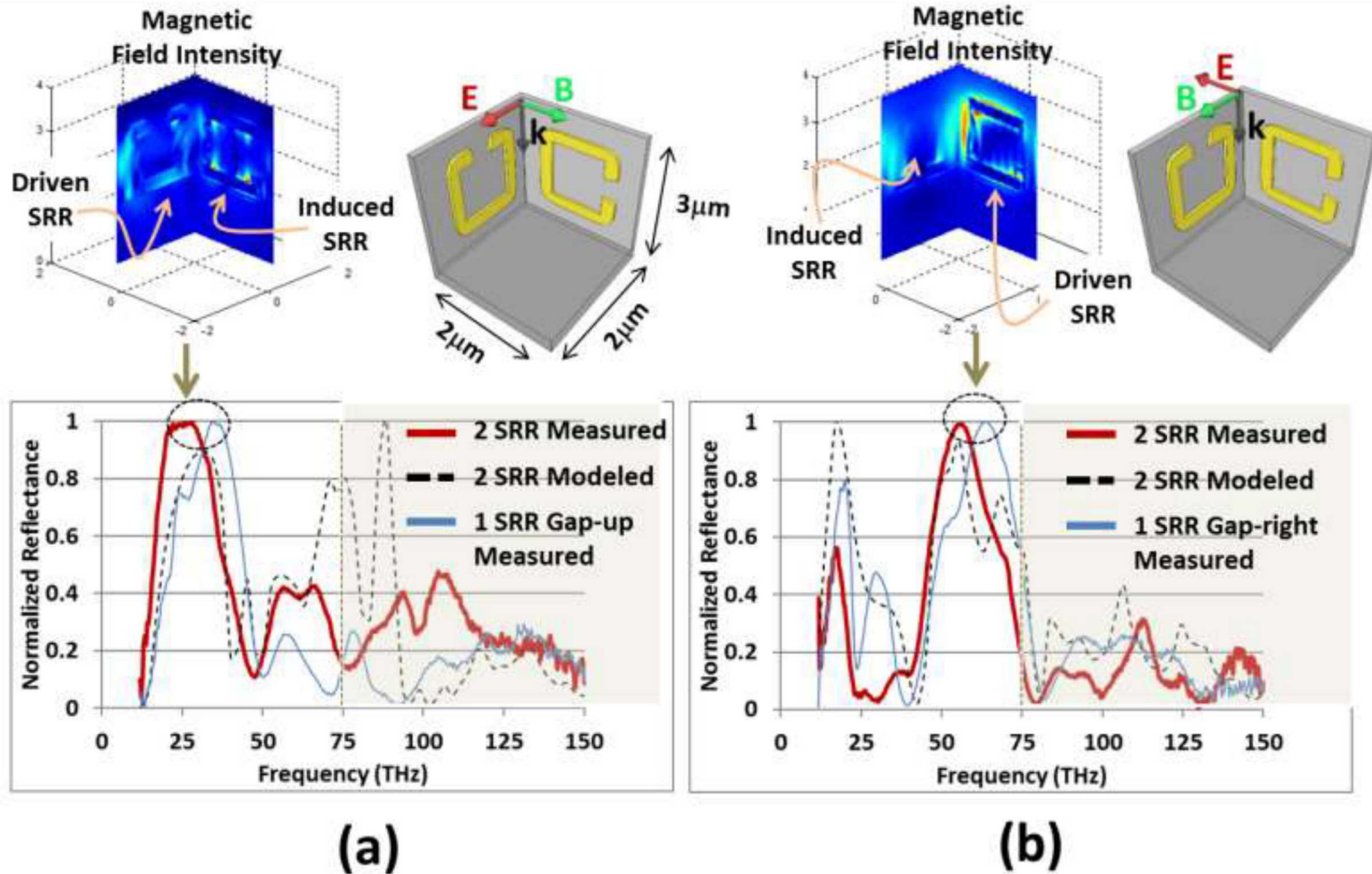
**Gap  
Down**



**(c)**

— Measured    --- RCWA-Modeled

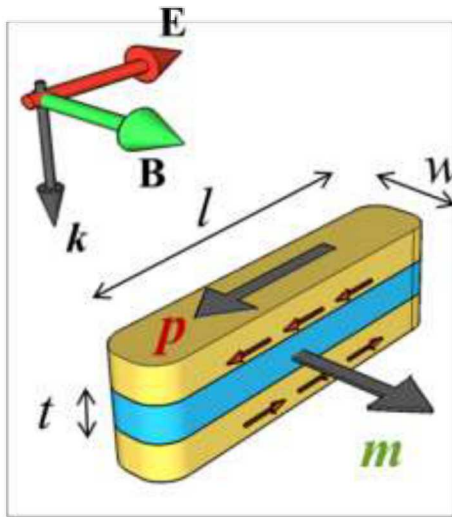
# 2-SRR Basis Unit Cell – Two Channels





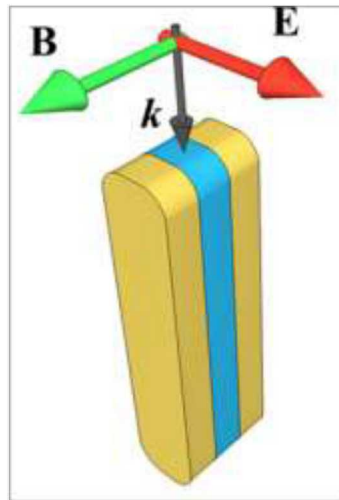
# 3D Cut-Wire Pair Coupling Mechanism

# Comparing Planar CWPs to Vertically Oriented CWPs



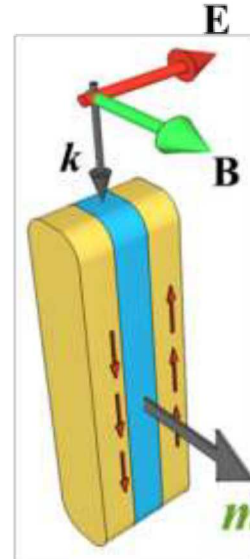
a)

**Planar CWP**



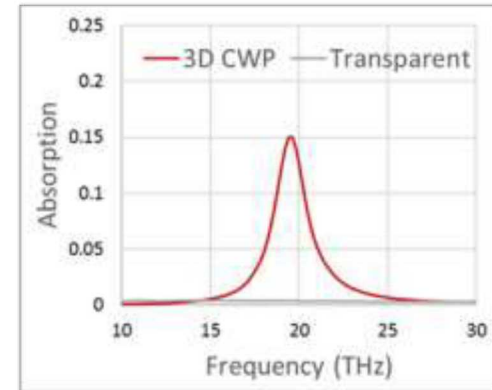
b)

**Transparent  
Polarization**



c)

**3D  
CWP**

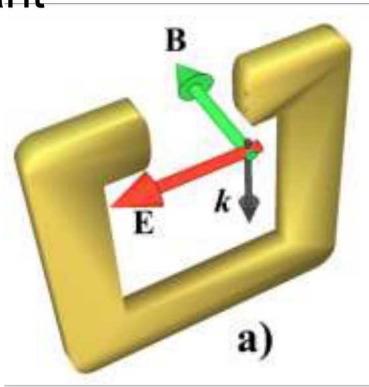


d)

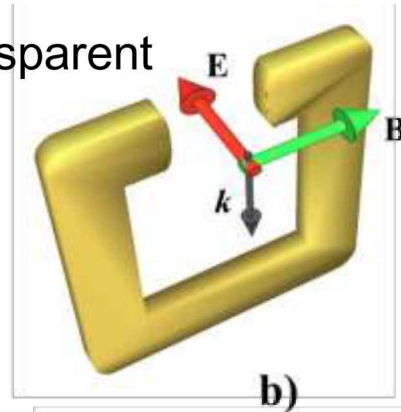
**Calculated  
Absorption Spectra**

D. Bruce Burckel, Bryan M. Adomanis, Michael B. Sinclair and Salvatore Campione, "Three-dimensional cut wire pair behavior and controllable bianisotropic response in vertically oriented meta-atoms," *Optics Express*, 25, 32198-32205, (2017).

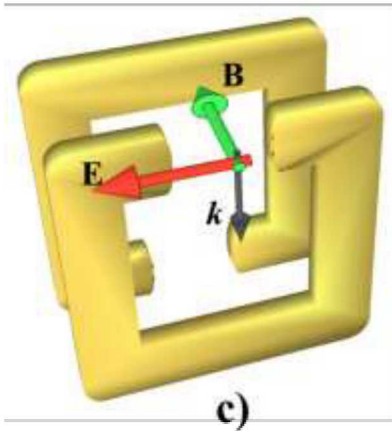
Resonant



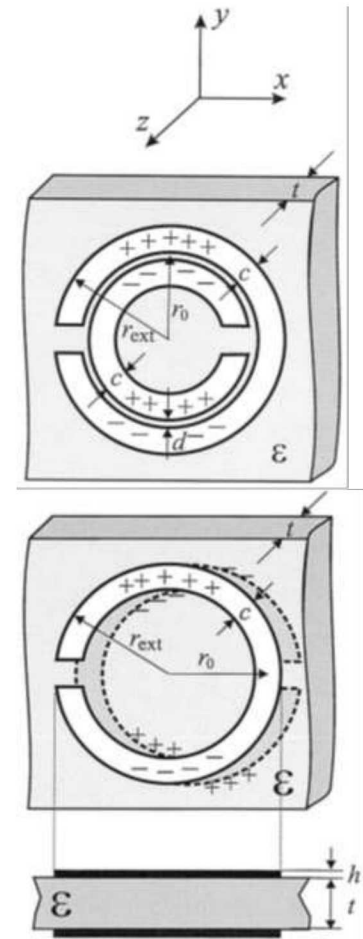
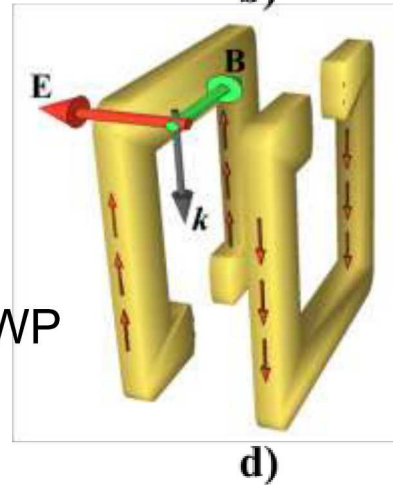
Transparent



Resonant

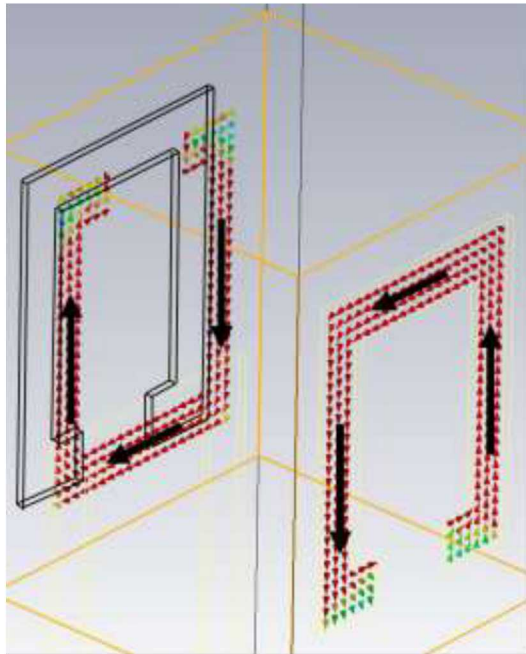


3D CWP



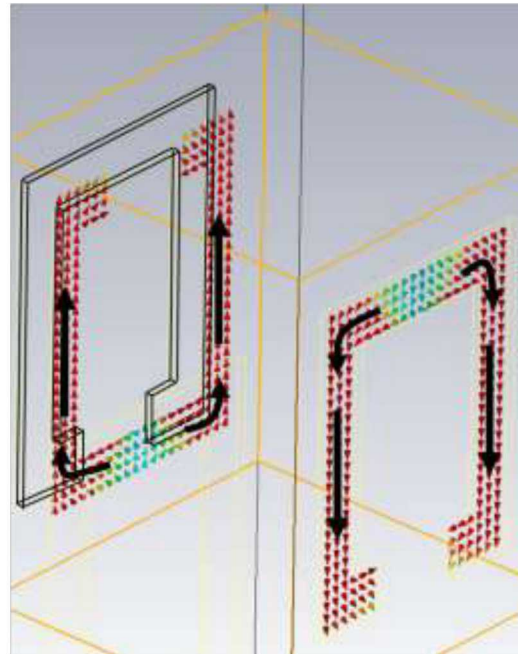
Submitted for publication

**Resonant  
Polarization**

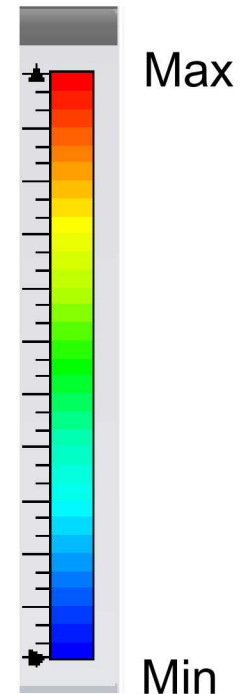


**a)**

**3D CWP  
Polarization**

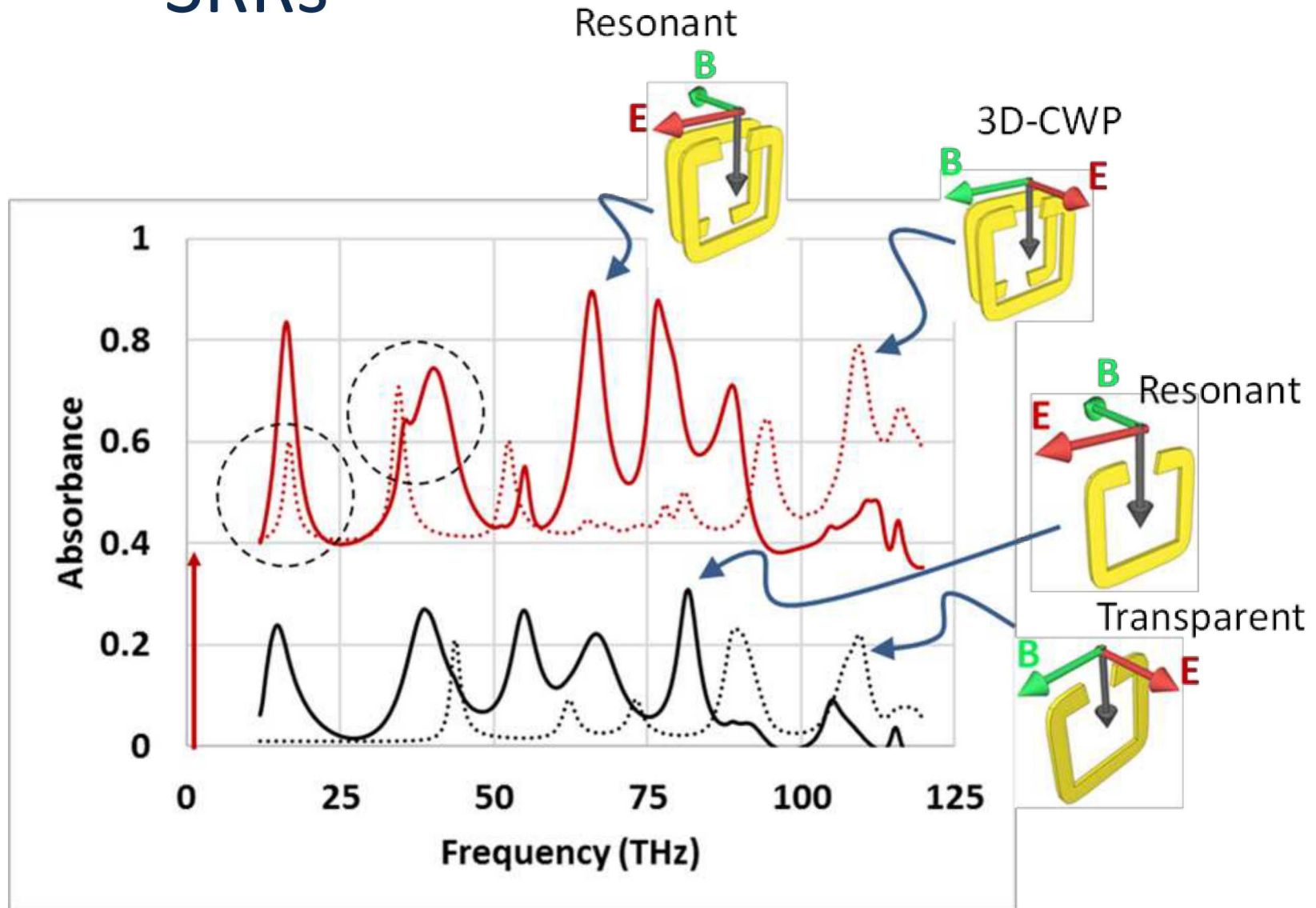


**b)**

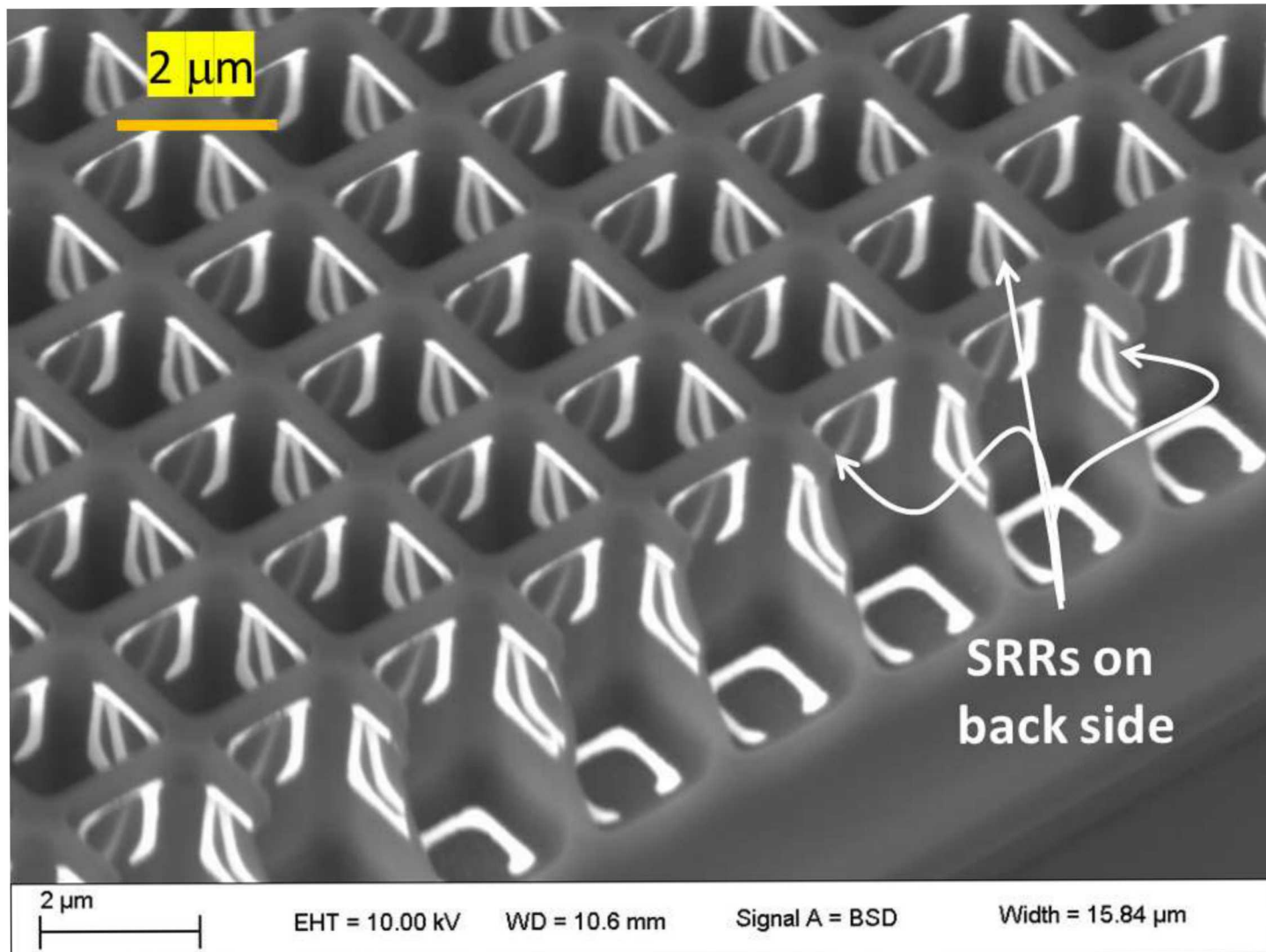


Submitted for publication

# Scattering Response for B2B SRRs

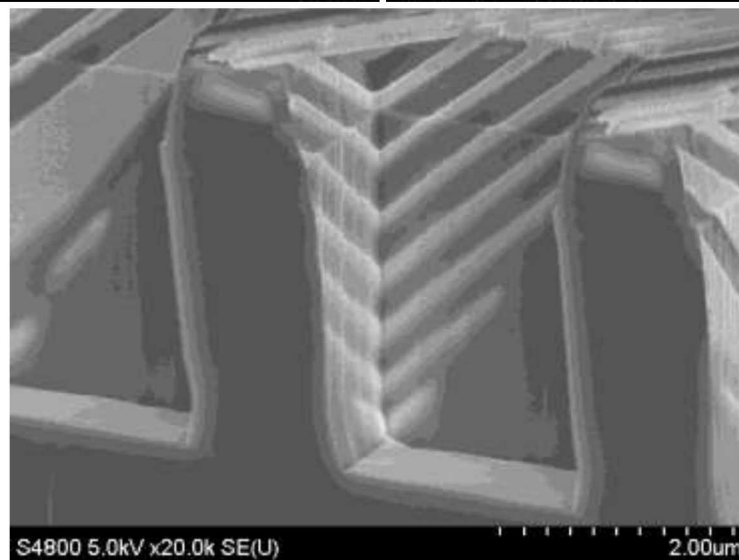
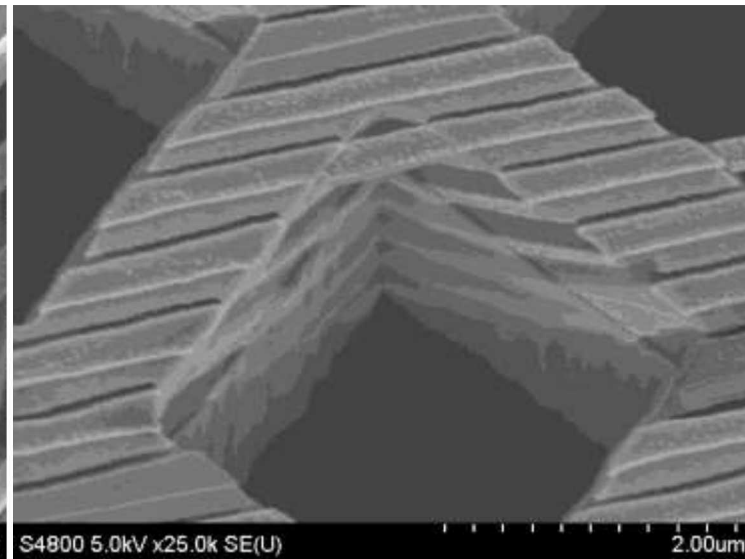
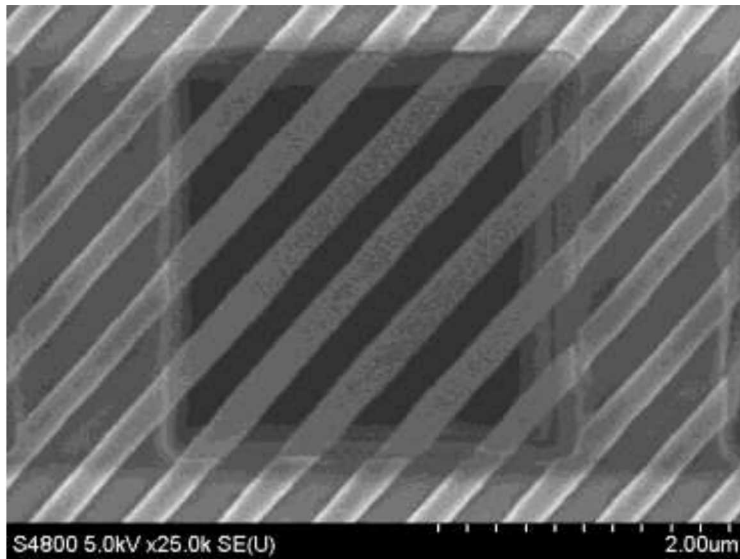


# Dense Metafilm Arrays





# Truly 3D Meta-atoms - Chevrons





# Summary



1. Membrane projection lithography is a versatile fabrication approach capable of fabricating a wide range of 3D metamaterial structures in CMOS compatible material systems.
2. Vertically oriented inclusions demonstrate coupling behaviors which cannot be duplicated by planar structures.
3. Even though CWP and SRRs have been studied for more than 10 Years, there are still subtleties to their scattering behavior which will impact how they perform in next-generation 3D metamaterial components.



# Collaborators



SNL (theory and modeling) – Salvatore Campione, Aaron Pung, Mike Sinclair, Igal Brener, Paul Davids

SNL (fabrication) – Paul Resnick, Kate Musick, Patrick Finnegan

Penn St. – Danny Zhu, Sawyer Campbell, Doug Werner

AFIT – Capt. Bryan Adomanis, Michael Marciniak



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3. Pin Chieh Wu, et. al., "Plasmon coupling in vertical SRR metamolecules," *Scientific Reports*, **5**, 9726 (2015).
4. Pin Chieh Wu, et. al., "Magnetic plasmon induced transparency in 3D metamolecules," *Nanophotonics*, **1**, 131-138 (2012).
5. Yi-Hao Chen, et. al., "Interplay of mutual electric and magnetic couplings between 3D SRRs," *Optics Express*, **25**, 2909 (2017).
6. Kebin Fan, et. al., "Stand-up magnetic metamaterials at THz frequencies," *Optics Express*, **19**, 12619 (2011).
7. D. Bruce Burckel, Paul J. Resnick, Patrick S. Finnegan, , Michael B. Sinclair and Paul S. Davids "Micrometer-scale fabrication of complex three dimensional lattice+basis structures in silicon," *Optical Materials Express*, , **5**, 2231-2239, (2015).
8. D. Bruce Burckel, Salvatore Campione, Paul S. Davids, and Michael B. Sinclair, "Three dimensional metafilms with dual channel unit cells," *Applied Physics Letters*, **110**, 143107, (2017).
9. D. Bruce Burckel and Salvatore Campione, "Vertically oriented metamaterial broadband linear polarizer," *Electronics Letters*, (submitted 2017).
10. Shalaev, et. al., "Negative index of refraction in optical metamaterials," *Optics Letters*, **30**, 3356-3359 (2005).
11. Cai, et. al., "Metamagnetics with rainbow colors," *Optics Express*, **15**, 3333-3341 (2007).
12. Shvets, et. al., "Negative index meta-materials based on two-dimensional metallic structures," *J. of Opt. A: Pure Appl. Opt*, **8**, S122-S130 (2006).
13. G. Dolling, et. al., "Cut-wire pairs and plate pairs as magnetic atoms for optical metamaterials," *Optics Letters*, **30**, 3198-3200 (2005).
14. Ricardo Marques, et. al., "Comparitive analysis of Edge- and Broadside- coupled SRRs for metamaterial design – theory and experiment," *IEEE Trans. On Ant. And Prop*, **51**, 2572-2581 (2003).